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Yamamoto et al.

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[54] **CONTROLLER FOR SEMI-CONDUCTOR PROCESSING MACHINE**

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[73] Assignee: **Hitachi, Ltd., Tokyo, Japan**

[**] Term: **14 Years**

[21] Appl. No.: **4,588**

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[30] **Foreign Application Priority Data**

Nov. 27, 1992 [JP] Japan 4-34702
[52] U.S. Cl. **D13/163**
[58] Field of Search 200/5 A, 5 R, 6 A, 6 R; 360/97, 98, 99, 132, 133, 431; 361/330, 331, 334, 335, 390, 391, 392, 393, 394, 415, 426; 369/132, 176, 178, 292; 395/118, 275; D13/123, 162, 163, 184; D14/102, 107

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[57] **CLAIM**

The ornamental design for a controller for semi-conductor processing machine, as shown.

DESCRIPTION

FIG. 1 is a front, top and right side elevational perspective view of a controller for semi-conductor processing machine showing our new design;
FIG. 2 is a front elevational view thereof;
FIG. 3 is a right elevational view thereof;
FIG. 4 is a left elevational view thereof;
FIG. 5 is a top plan elevational view thereof;
FIG. 6 is a bottom plan elevational view thereof; and,
FIG. 7 is a rear elevational view thereof.



FIG. 1



FIG. 2

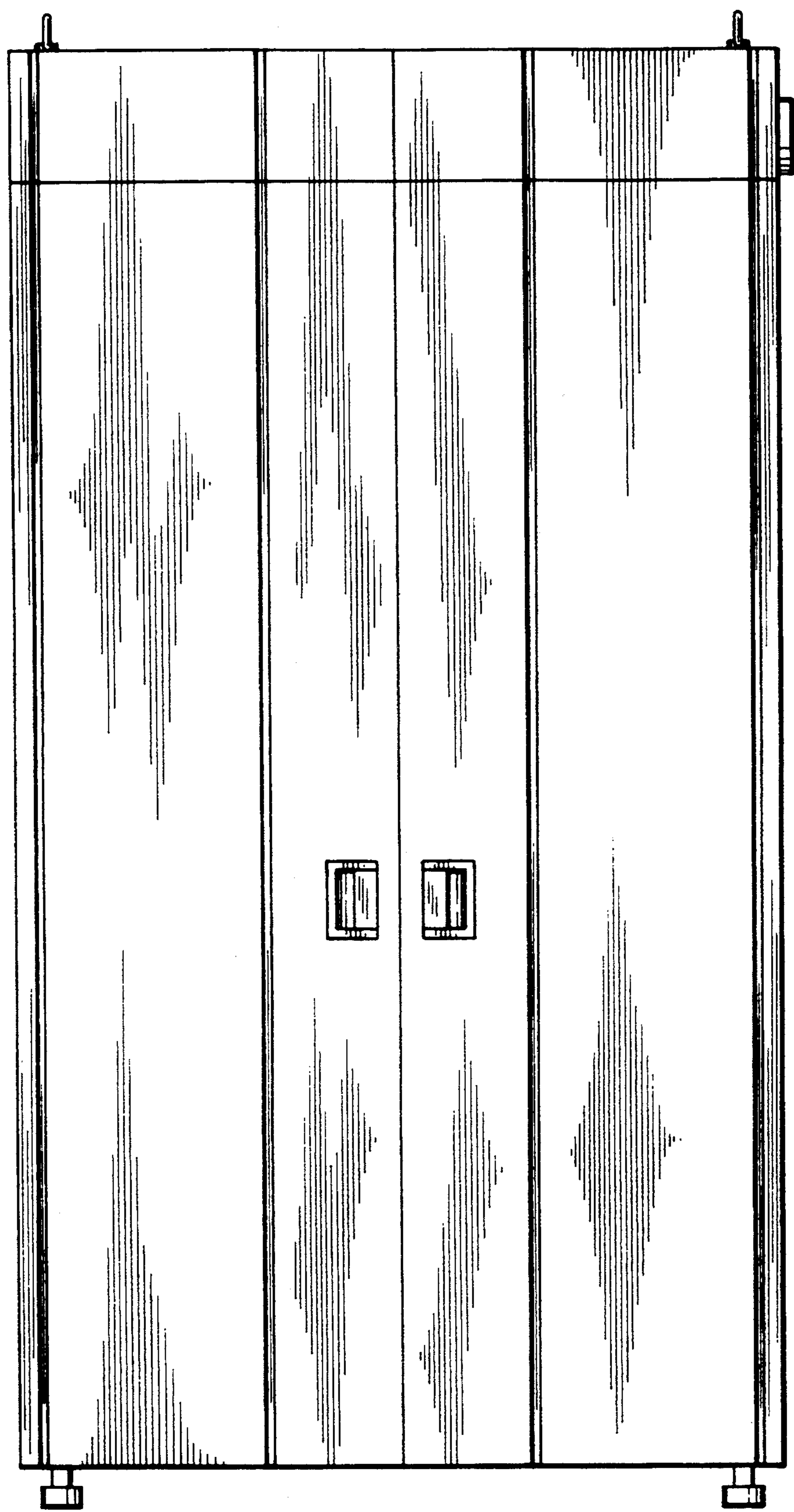


FIG. 3

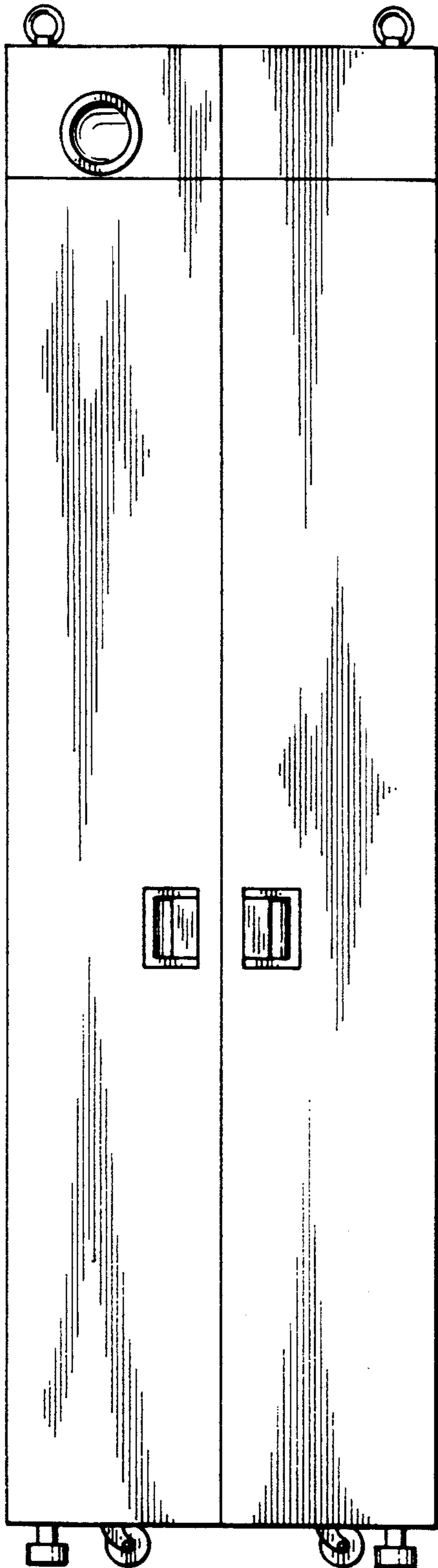


FIG. 4

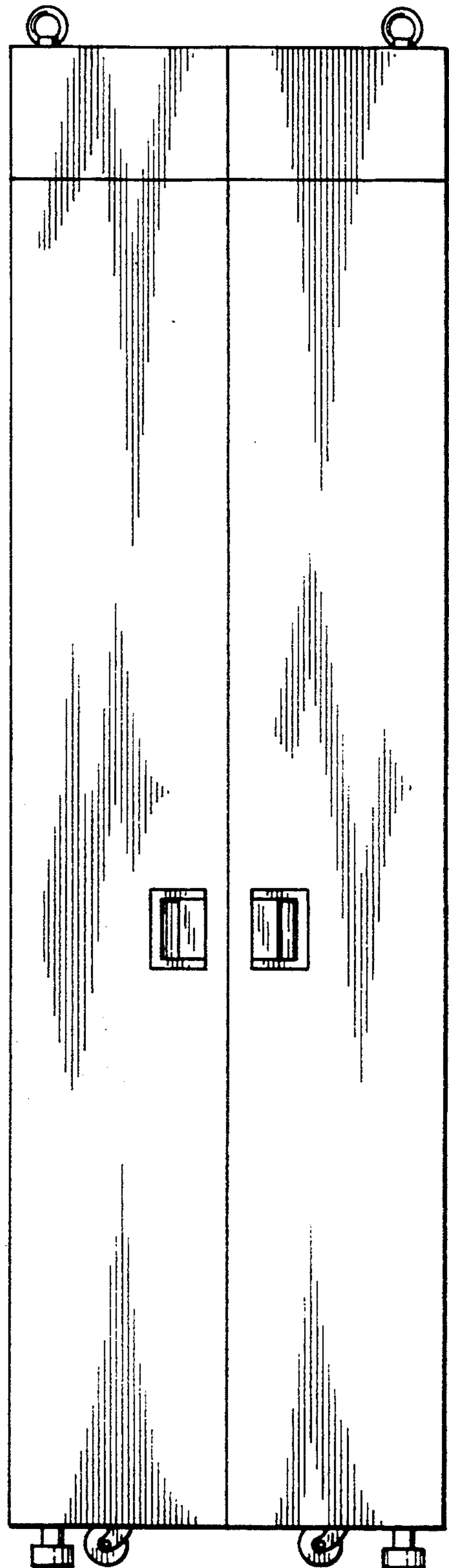


FIG. 5

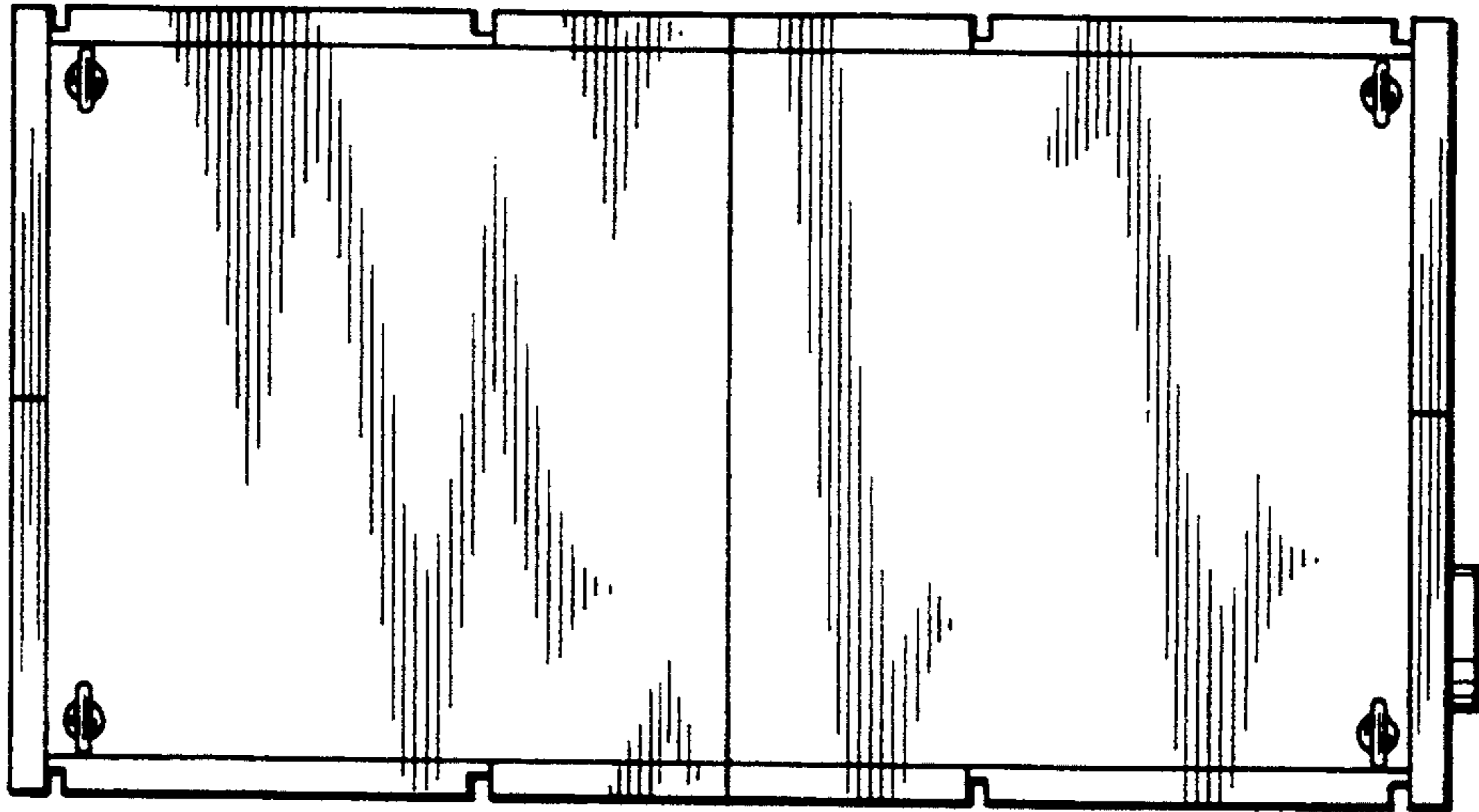


FIG. 6

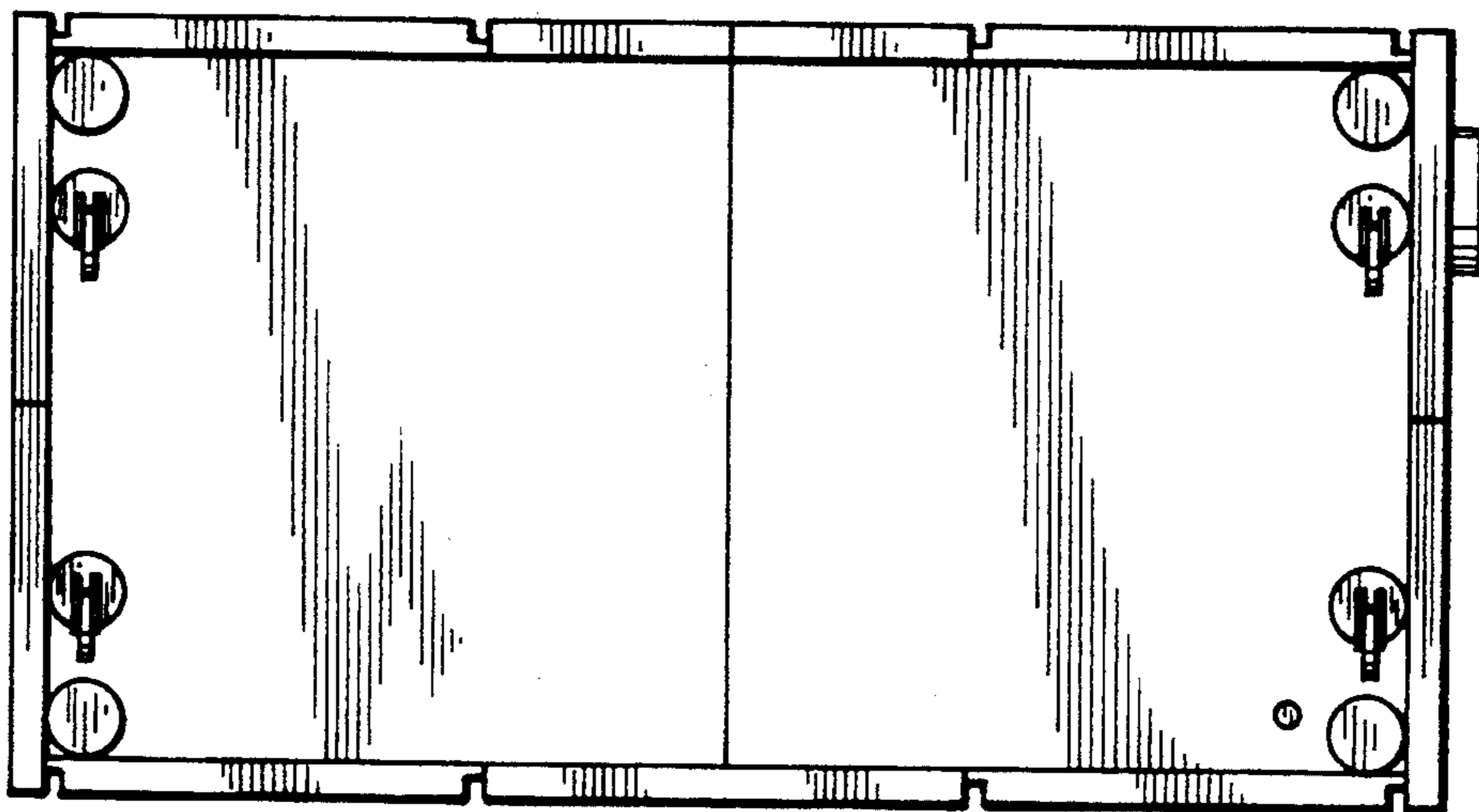


FIG. 7

